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PATENT
04087-P0001A WWW/HJP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Tim Sievers, <i>et al.</i>
Application No. 10/719,585	Filing Date: November 21, 2003
Title of Application:	Method and Apparatus for the Production of a Workpiece of Exact Geometry
Confirmation No. 3272	Art Unit: 1732
Examiner	

Commissioner for Patents
Post Office Box 1450
Alexandria, VA 22313-1450

Information Disclosure Statement by Applicants

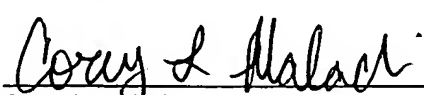
As a means of complying with the duty of disclosure set forth in 37 CFR §1.56, Applicant lists the following references (copies of the listed patents and papers enclosed). This IDS is being filed pursuant to 37 CFR §1.97(c)(2), and the \$180.00 fee required by 37 CFR §1.17(p) is enclosed. The Commissioner is hereby authorized to charge any fee deficiencies and to credit any overpayments to Deposit Account No. 19-4516.

Foreign Patent Documents			
Exam. Initials	Document No.	Date	Country
	2000-73108	03/07/2000	JP (with English abstract)

Other Documents	
Exam. Initials	Description (Author, Title, Date, Pages, etc)
	Translation of Japanese Office Action, 4 July 2006, 2 pages.

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October 31, 2006



Corey L. Malachi

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The listed patents pertain in a general way to the subject matter of the application, but are not necessarily considered to be analogous prior art.

Respectfully submitted,

October 31, 2006



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Date Considered

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